Se	arçn	Notes	

Application/Control No.	Applicant(s)/Patent under Reexamination
10/050,195	KANG ET AL.
Examiner	Art Unit
Junghwa M. Im	2811

SEARCHED			
Class	Subclass	Date	Examiner
257	767,768 769,770 295,753	8/1/2003	JMI
257	774	8/1/2003	JMI
above	updated	5/24/2006	JMI
		13000 3000	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
EAST (uspat, uspub, epo, jpo, der, ibm)	5/24/2006	JMI